

10540873 - GAU: 4172

JC10 Rec'd PCT/PTO 15 JUL

T AND TRADEMARK OFFICE IN THE UNITE

IN RE APPLICATION OF: Noriva IZU, et al

SERIAL NO:

10/540.873

GAU: June 27, 2005 EXAMINER:

FOR: PROCESS FOR PRODUCING OXYGEN PARTIAL PRESSURE DETECTING PART OF RESISTANCE

OXYGEN SENSOR

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

FILED:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR \$1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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EFS-Web Receipt date: 07/15/2005

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Form PTO 1449 U.S. DEPARTMENT OF COMMERCE (Modified) PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO. 274380USOPCT 774ADENNMT 10/540,873					
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*				APPLICANT				
LIST OF REFERENCES CITED BY APPLICANT				Noriya IZU, et al.				
7				FILING DATE		GROUP		
	*			June 27, 2005				
				U.S. PATENT DOCUMENTS				
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB FILING DATE CLASS IF APPROPRIATE		
	AA							
	AB							
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		DOCUMENT NUMBER	DATE	COUNTRY			TRANSLATION YES NO	
	AO	56-058652	05/21/1981	JP(with English abstract)				NO
	AP	55-137334	10/27/80	JP(with English abstract)				NO
	AQ	62-174644	07/31/87	JP(with English abstract)				NO
	AR	07-063719	03/10/95	JP(with English abstract)				NO
	AS	2002-255515	09/11/02	JP(with English abstract)				NO
	AT							
		OTHER RE	FERENCES (Including Author, Title, Date, Pertinent	Pages, et	c.)		
	AU			Sensors Based on Fine Powders of Certient B. nages 151-153. December 4, 2001		repared b	y Mist F	Pyrolysis*,
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	AW	Ho. 1, Belle of al., "Oxygen Gas Sensors Based on CeO2 Thick and Thin Films", Sensors and Actuators B, Vol. 4, No. 3, pages 393-399, July 5, 1991.						
	AX	T. IVERS-TIFFEE et al., "ELECTRONIC CONDUCTIVITY OF CERIA", High Tech. Ceramics, pages 1933 to 1941, October 23, 1987.						
	AY	Noriya IZU et al., "Sanka Cerium Biryushi o Mochilla Teikogata Sanso Gas Sensors", The Ceramic Society of Japan, Dai 14 VX Kai Shuki Symposium Koen Yokoshu, page 14, September 26, 2001.						
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Examiner	N/I ==1						18/2008	
*Examiner: In conformance	itial if n	eference is considered,	whether or not	citation is in conformance with MPEP 60	9; Draw lir	e through	citation	if not in



U.S. PCT Application Serial No.: 10/540,873 Docket No.: 274380US0PCT

STATEMENT OF RELEVANCY

1) References <u>AO and AU-AY</u> have been cited in the International Search Repor Copies of these references are being submitted herewith only when not automatically provided by the International Searching Authority.
2) Reference have been cited in the corresponding Search Report. A copy of this reference is being submitted herewith.
3) References <u>AP-AS and AZ</u> are discussed in the specification. A copy of thes references is being submitted here with.
4) Referenceis additional prior art known to Applicant. A copy of these references is being submitted herewith.